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Case No. 10200/103

DECLARATION FOR PATENT APPLICATION

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled In Situ Deposition Of A Nitride Layer And Of An Anti-Reflective Layer, the specification of which:

Situ Deposition (Of A Nitride Layer And Of A	n Anti-Reflective Layer, the specification	on or which	
Ø	is attached hereto.			
	was filed on as Appli	ication Serial No		
		(if applicable).		
I hereby state th	nat I have reviewed and under	erstand the contents of the above-ident	ified specification, i	ncluding the claims, as
I acknowledge	the duty to disclose informat	tion which is material to the patentabil	of any foreign and	lication(s) for patent or
inventor's certif	ficate of 9 303(a) of any re	der 35 U.S.C. § 119(a)-(d) or § 365(b) T International application which des entified below, by checking the box, an having a filing date before that of the ap	e foreign application	for patent or inventor's riority is claimed:
				Priority Claimed
Prior Foreign A	pplication(s)			
	r) (Country)	(Day/Month/Year	Filed)	Yes No
(Number	r) (Country)			l below:
I hereby claim	the benefit under 35 U.S.C. §	119(e) of any United States provisional	· -FF	
		(D) - D-4-)	-	
(Appli	cation Serial No.)	(Filing Date)		r DCT International
application des	signating the United States, indicated States of the prior United States of	C. § 120 of any United States applications and states applications and the subject π or PCT International application in the slisclose information which is material date of the prior application and the nations.	manner provided by to patentability as di tional or PCT Intern	the first paragraph of 35 efined in 37 CFR § 1.56 lational filing date of this
	O. C. L. No.	(Filing Date)	(Status-patente	ed, pending, abandoned)
I hereby decla belief are beli	eved to be true; and further t	erein of my own knowledge are true an hat these statements were made with the imprisonment, or both, under Section 1 ardize the yandity of the application or a	d that all statements be knowledge that wi 001 of Title 18 of th	made on information and illful false statements and the United States Code and
Inventor's Sig	nature	Morn Faday	Date.	
Full name of	sole or first inventor	Sharmin Sadoughi	95014	
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NO. 4865 P. 5

Case No. 10200/10	<u>):</u>
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Inventor's Signature	
Full name of second joi	nt inventor, if any
Residence	
Citizenship	
Post Office Address	

Kraecell	Date:	11/5/01
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NO. 4872 P. 2

Case No. 10200/103

Inventor(s):

Sharmin Sac shi and Krishnaswa

Title:

IN SITU DEPOSITION OF A NITRIDE LAYER AND OF AN ANTI-REFLECTIVE LAYER

amy Ramkumar			
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POWER	OF.	ATT	OR	NE'
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• `	POWER OF ATTORNEY			
	The specification of the above-identified patent application:			
\boxtimes	is attached hereto was filed on as application Serial No.			
attorney	I hereby revoke all previously granted powers of attorney in the above-identified patent application and appoint the following s to prosecute said patent application and to transact all business in the Patent and Trademark Office connected therewith:			
	Paul E. Rauch, Ph.D Reg. No. 38,591			
	David Rozenblat - Reg. No. 47,044			
	Andrew D. Fortney, Ph.D Reg. No. 34,600			
	Please address all correspondence and telephone calls to <u>David Rozenblat</u> in care of:			
	Brinks Hofer Gilson & Lione P.O. Box 10395 Chicago, IL 60610 (312)321-4200			
he pater	Cypress Semiconductor Corp., a Delaware corporation, certifies that it is the assignce of the entire right, title and interest in application identified above by virtue of either:			
3	An assignment from the inventor(s) of the patent application identified above, a copy of which is attached hereto. OR			
	An assignment from the inventor(s) of the patent application identified above. The assignment was recorded in the Patent and Trademark Office at Reel, frame OR			
	A chain of title from the inventor(s), of the patent application identified above, to the current assignee as shown below:			
- -	 From To: The document was recorded in the Patent and Trademark Office at Reel, frame, or a copy thereof is attached. 			
	2. From To: The document was recorded in the Patent and Trademark Office at Reel, frame, or a copy thereof is attached.			
.	Additional documents in the chain of title are listed on a supplemental sheet.			
above ar	The undersigned has reviewed the assignment or all the documents in the chain of title of the patent application identified and, to the best of undersigned's knowledge and belief, title is in the assignee identified above.			
	The undersigned (whose title is supplied below) is empowered to act on behalf of the assignee.			
ike so n	I hereby declare that all statements made herein of my own knowledge are true, and that all statements made on information of are believed to be true; and further, that these statements are made with the knowledge that willful false statements, and the nade, are punishable by fine or imprisonment, or both, under Section 1001. Title 18 of the United States Code, and that such alse statements may jeopardize the validity of the application or any patent issuing thereon. Date: 11600			
Vame:	Andrew D. Fortney, Ph.D., Esq.			
Title:	Senior Corporate Counsel/Director of Intellectual Property			
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